

25 April 2003

09829,848

L Number	Hits	Search Text	DB	Time stamp
-	4	6214193.pn. 6099702.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 11:32
-	2	3950184.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 11:58
-	14	3950184.URPN.	USPAT	2003/04/25 11:58
-	5	("3141793"   "3656173"   "3950184"   "4451507"   "5084483").PN.	USPAT	2003/04/25 12:01
-	17	("3798056"   "3950184"   "4339319"   "4373988"   "4466864"   "4856456"   "5000827"   "5169408"   "5312487"   "5340437"   "5472592"   "5670034"   "5677000"   "5893966"   "5930549"   "6077412"   "6099702").PN.	USPAT	2003/04/25 13:58
-	33	5000827.URPN.	USPAT	2003/04/25 12:04
-	53	5169408.URPN.	USPAT	2003/04/25 12:41
-	33	5000827.URPN.	USPAT	2003/04/25 12:50
-	2247	204/212,225,237,275.1.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 13:58
-	773	204/224r.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 13:58
-	2837	204/212,225,237,275.1.ccls. 204/224r.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:00
-	2190	118/416,500,501.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:01
-	5015	(204/212,225,237,275.1.ccls. 204/224r.ccls.) 118/416,500,501.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:01
-	1027	((204/212,225,237,275.1.ccls. 204/224r.ccls.) 118/416,500,501.ccls.) and (semiconductor or wafer)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:02
-	557	(((204/212,225,237,275.1.ccls. 204/224r.ccls.) 118/416,500,501.ccls.) and (semiconductor or wafer)) and (spinning or spin or spun or rotate or rotated or rotating)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:02

-	90	(((204/212,225,237,275.1.ccls. 204/224r.ccls.) 118/416,500,501.ccls.) and (semiconductor or wafer)) and (spinning or spin or spun or rotate or rotated or rotating)) and (recycle or recycling or recylcer or reclaim or reclamation or recycled or reclaimed or recover or recovered or recovery or recovering) ("5922138"   "6168691"   "6187152").PN.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:36
-	3	6352623.URPN.	USPAT	2003/04/25 14:29
-	0	205/122,123,157,220.ccls. 427/98,299,352.ccls.	USPAT	2003/04/25 14:33
-	3776	(205/122,123,157,220.ccls. 427/98,299,352.ccls.) and (semiconductor or wafer)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:34
-	940	((205/122,123,157,220.ccls. 427/98,299,352.ccls.) and (semiconductor or wafer))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:34
-	504	((205/122,123,157,220.ccls. 427/98,299,352.ccls.) and (semiconductor or wafer)) and (cleaning or clean or cleaned or rinsed or rinse or rinsing or wash or washing or washed)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:35
-	53	((205/122,123,157,220.ccls. 427/98,299,352.ccls.) and (semiconductor or wafer)) and (cleaning or clean or cleaned or rinsed or rinse or rinsing or wash or washing or washed)) and (recycle or recycling or recylcer or reclaim or reclamation or recycled or reclaimed or recover or recovered or recovery or recovering)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:36
-	90	(((204/212,225,237,275.1.ccls. 204/224r.ccls.) 118/416,500,501.ccls.) and (semiconductor or wafer)) and (spinning or spin or spun or rotate or rotated or rotating)) and (recycle or recycling or recylcer or reclaim or reclamation or recycled or reclaimed or recover or recovered or recovery or recovering)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 15:01
-	53	(((205/122,123,157,220.ccls. 427/98,299,352.ccls.) and (semiconductor or wafer)) and (cleaning or clean or cleaned or rinsed or rinse or rinsing or wash or washing or washed)) and (recycle or recycling or recylcer or reclaim or reclamation or recycled or reclaimed or recover or recovered or recovery or recovering)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:37
-	225	((205/122,123,157,220.ccls. 427/98,299,352.ccls.) and (semiconductor or wafer)) and (cleaning or clean or cleaned or rinsed or rinse or rinsing or wash or washing or washed)) and (spin or spinning or spun or rotate or rotating or rotated or revolve or revolved or revolving)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:37

	40	(((205/122,123,157,220.ccls. 427/98,299,352.ccls.) and (semiconductor or wafer)) and (cleaning or clean or cleaned or rinsed or rinse or rinsing or wash or washing or washed)) and (spin or spinning or spun or rotate or rotating or rotated or revolve or revolved or revolving)) and (recycle or recycling or recycler or reclaim or reclamation or recycled or reclaimed or recover or recovered or recovery or recovering)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/04/25 14:37
--	----	--	---	---------------------